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## Crystal Growth of Germanium-Silicon Alloys on the ISS

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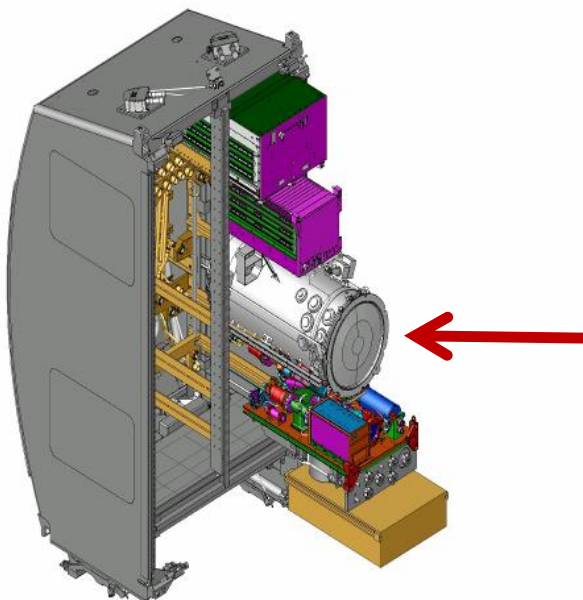
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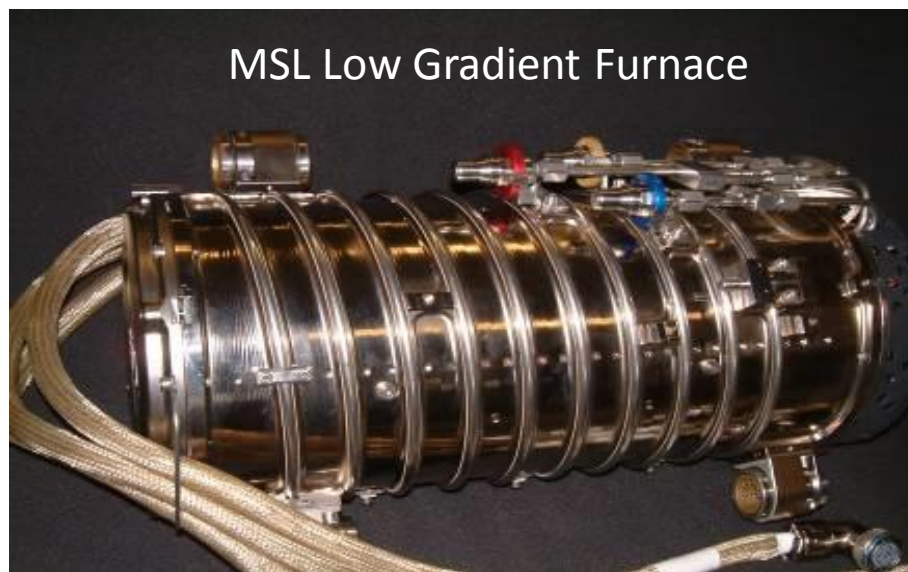


# ICESAGE Flight Investigation

- “Influence of Containment on the Growth of Silicon-Germanium” (ICESAGE) is a NASA Materials Science Flight Investigation
- ICESAGE is a collaborative investigation between NASA and the European Space Agency (ESA)
- The ICESAGE experiments will be conducted in the Low Gradient Furnace (LGF) in the Materials Science Laboratory on the International Space Station (ISS)



Materials Science Laboratory

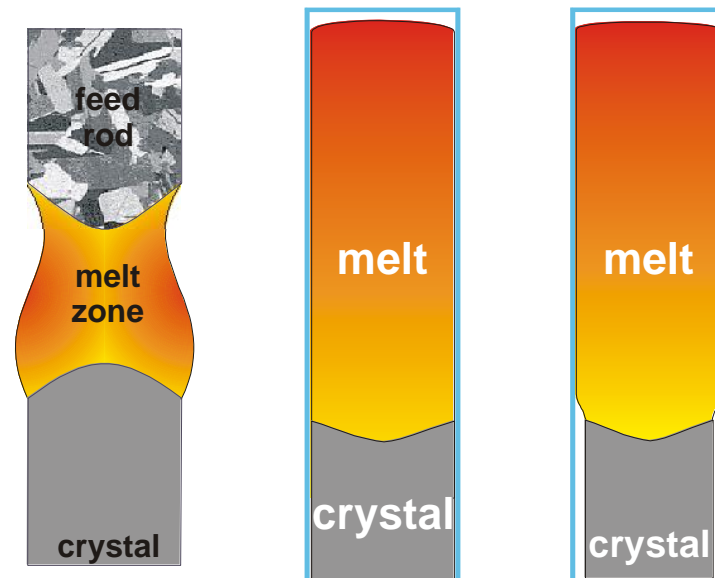


MSL Low Gradient Furnace

# Overview of the Investigation

This investigation involves the comparison of results achieved from three types of crystal growth of germanium and germanium-silicon alloys:

- Float zone growth
- Bridgman growth
- Detached Bridgman growth

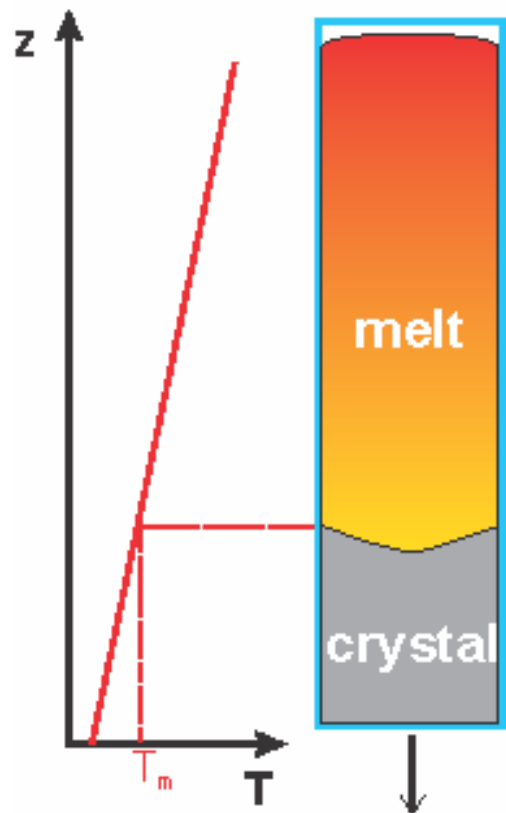


The fundamental goal of the proposed research is to determine the influence of containment on the processing-induced defects and impurity incorporation in germanium-silicon (GeSi) crystals (silicon concentration in the solid up to 5 at%) for three different growth configurations in order to quantitatively assess the improvements of crystal quality possible by detached growth.

# What is Detached Bridgman Growth?

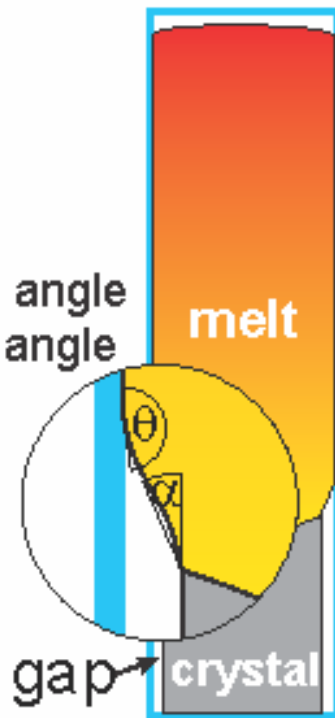
Sufficient condition for detachment<sup>1,2</sup>:  
 $(\alpha + \theta \geq 180^\circ)$

**Bridgman growth**



**Detached Bridgman**

$\alpha$ : growth angle  
 $\theta$ : wetting angle



## Advantages

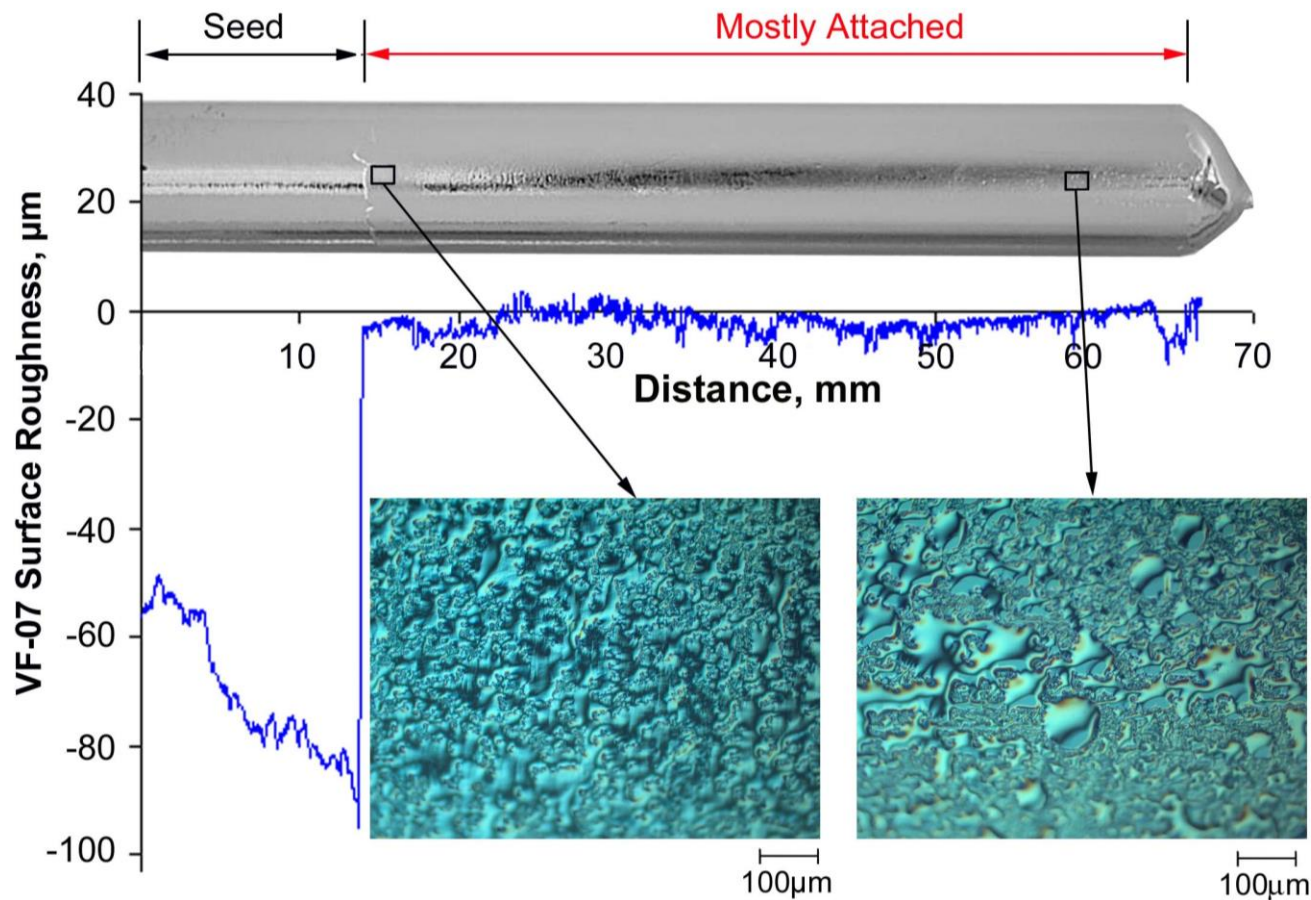
- No sticking of the crystal to the ampoule wall
- Reduced stress
- Reduced dislocations
- No heterogeneous nucleation by the ampoule
- Reduced contamination

<sup>1</sup>V. S. Zemskov:  
 Fiz. Khim. Obrab. Mater. 17 (1983) 56

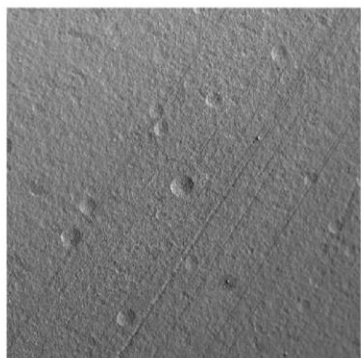
<sup>2</sup>T. Duffar, I. Paret-Harter, P. Dusserre:  
 J. Crystal Growth 100 (1990) 171.



# “Attached” Germanium



pBN Ampoule Surface

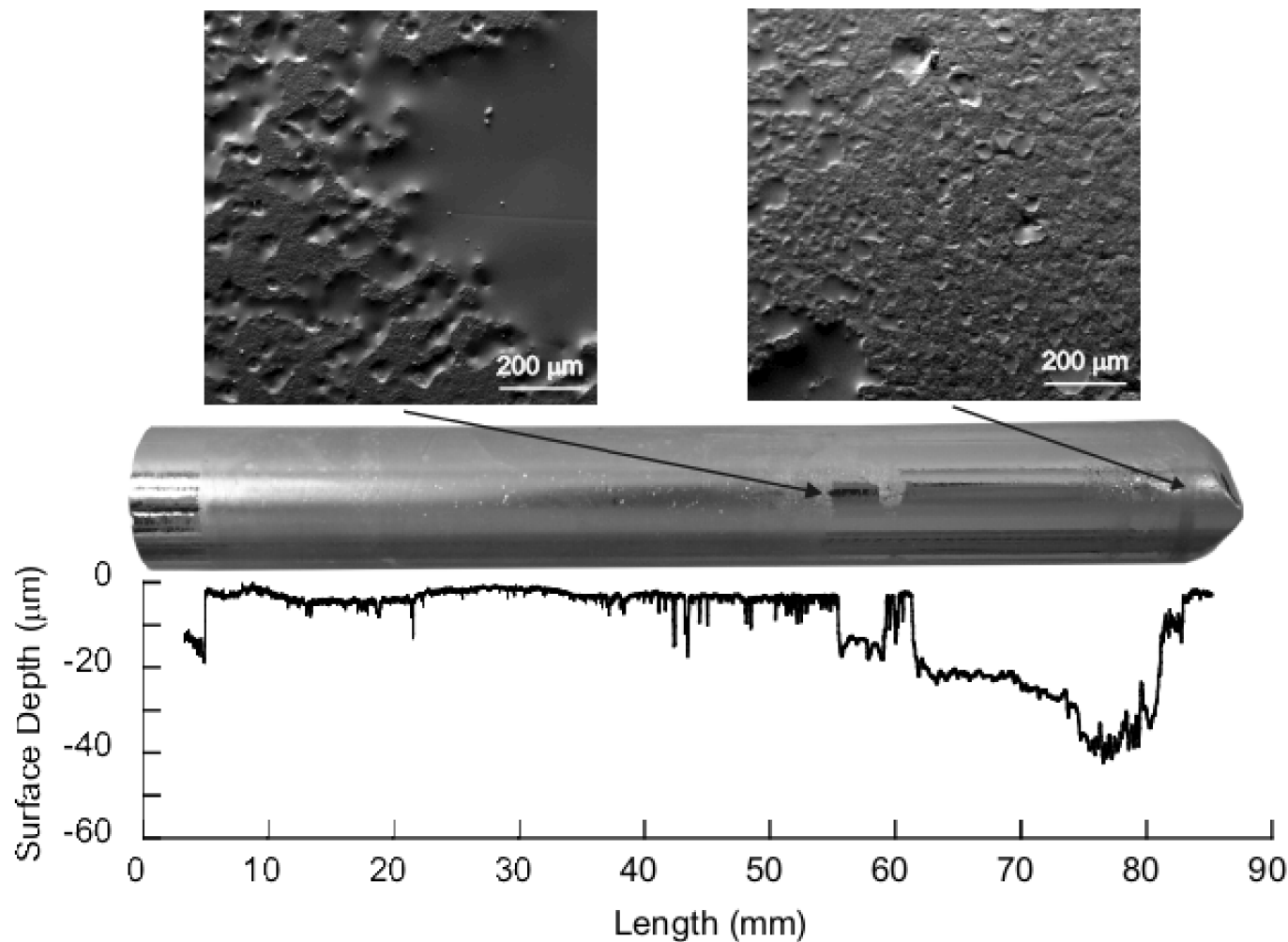


200  $\mu\text{m}$

100  $\mu\text{m}$

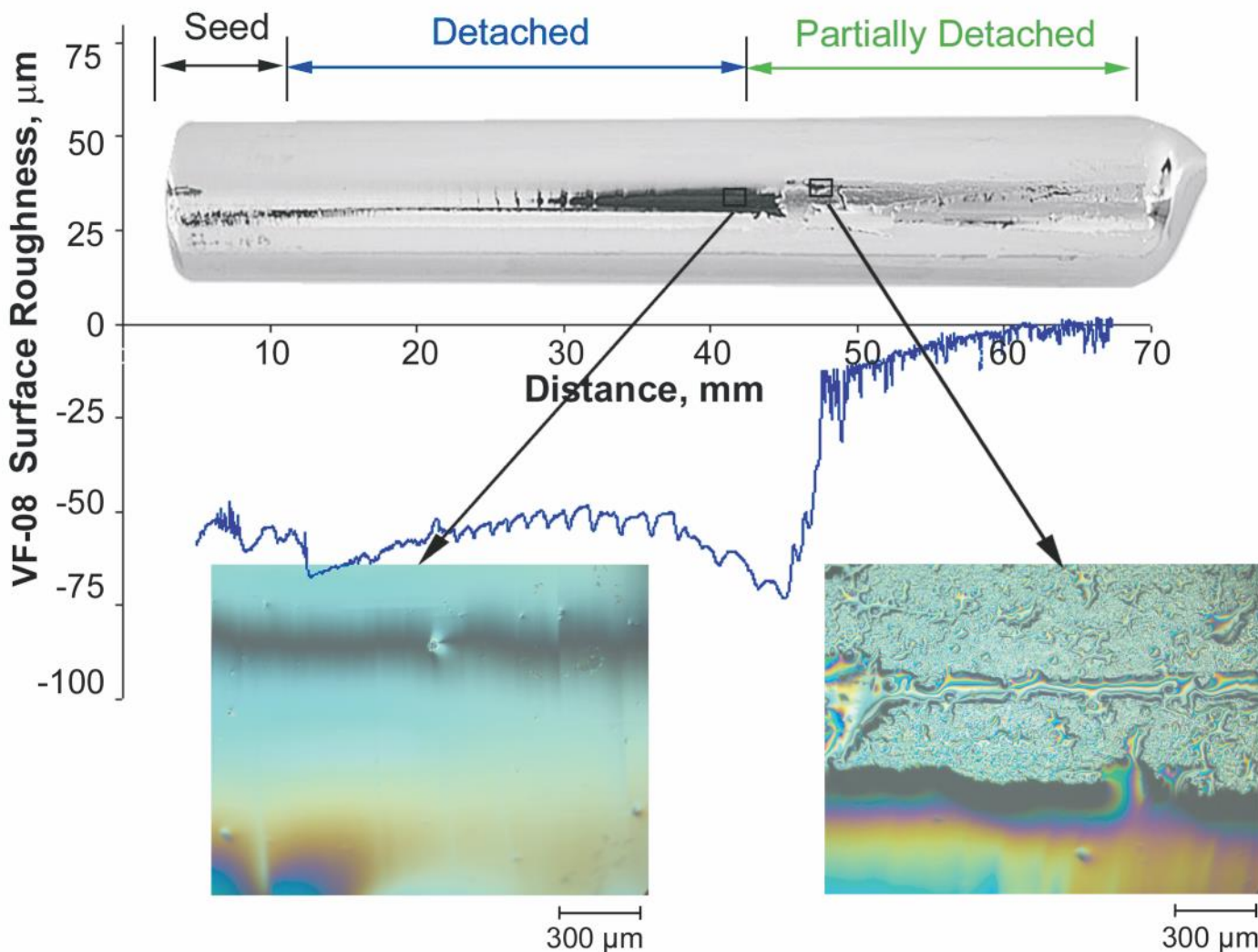
100  $\mu\text{m}$

# Partially Attached GeSi



M. P. Volz, M. Schweizer, N. Kaiser, S. D. Cobb, L. Vujisic, S. Motakef, F. R. Szofran, *JCG* 237-239 (2002) 1844-1848

# Detached Ge in pBN Ampoule



# Etch Pit Densities in Detached/Attached Crystals

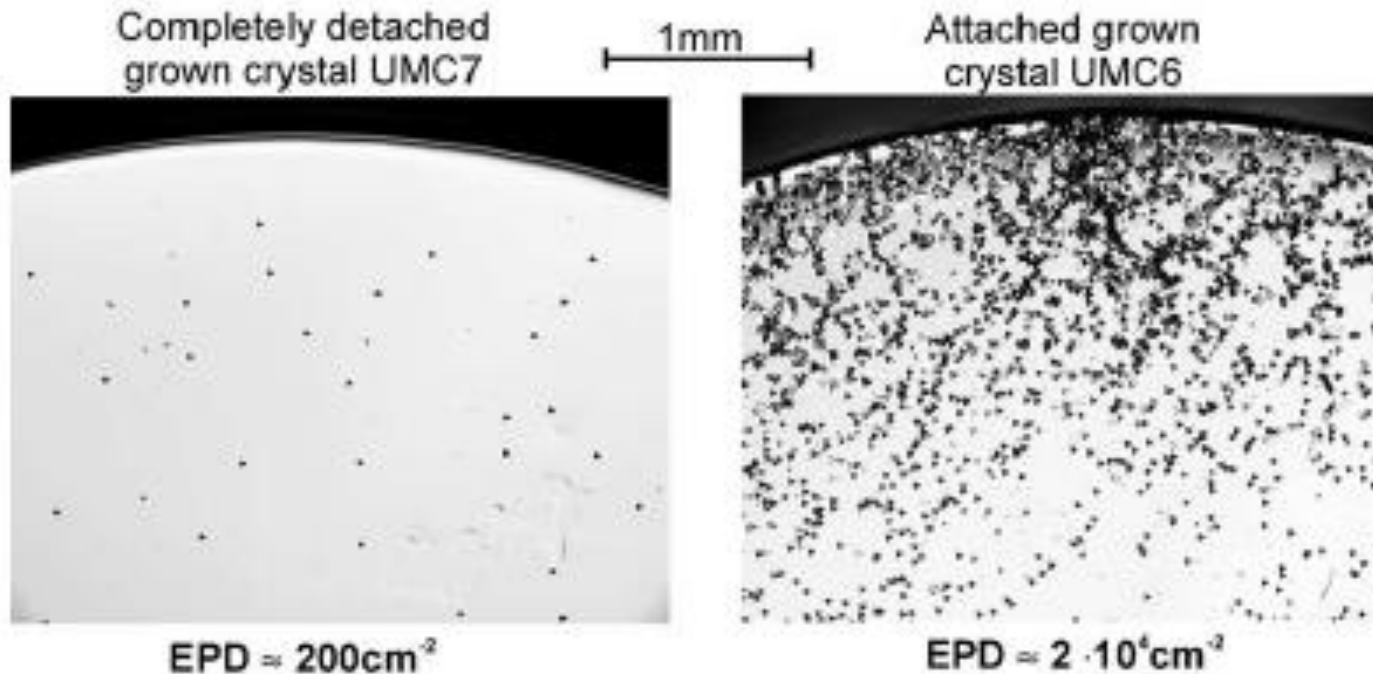


Fig. 5. Micrograph from the detached-grown sample UMC7 and from the attached-grown sample UMC6.

M. Schweizer, S. D. Cobb, M. P. Volz, J. Szoke, F. R. Szofran,  
JCG 235 (2002) 161-166





# Serendipitous Observations of Detached Growth in Microgravity



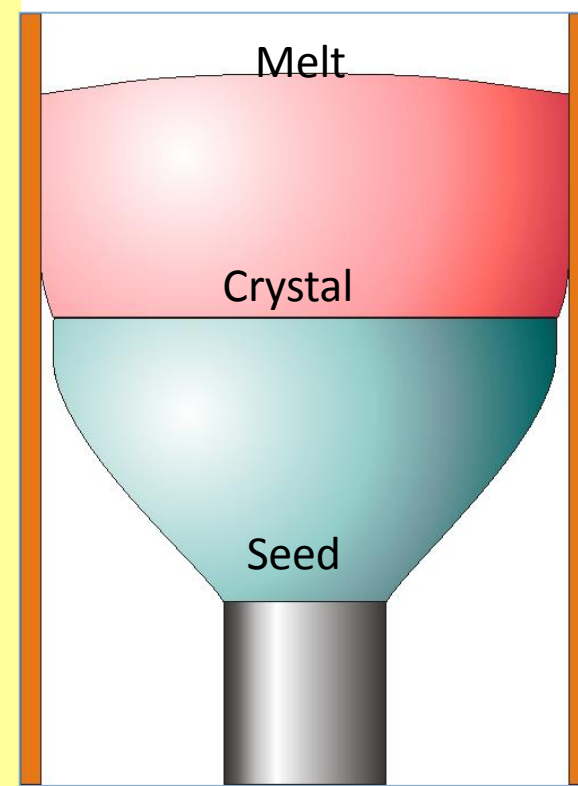
- **Microgravity experiments have yielded detached ingots that have one or more of the following characteristics (Regel and Wilcox, Microgravity Science and Technology, 1999):**
  - Free movement in container after growth
  - Isolated surface voids or bubbles
  - Surface ridges and lines
  - Contact only at peaks of grooved ampoules
  - Gap of 1-60  $\mu\text{m}$  between ingot and wall after accounting for thermal contraction
  - Large gap ( $>1$  mm) with a wavy surface or hourglass-shaped neck next to seed
- **Occurrence of detachment is unpredictable (Regel and Wilcox, Microgravity Science and Technology, 1999):**
  - Predominately observed in semi-conductors but also in metals and alloys
  - Occurs at fast and slow growth rates
  - Independent of dopant
  - Features of detachment not reproducible
  - Occurrence of detachment not reproducible
  - Independent of oxygen presence



# Motivation for Flight Experiments

*ICEAGE seeks a better understanding of detachment by conducting a series of microgravity experiments in which the relevant parameters are varied*

- What are the conditions for detachment in microgravity and how do they depend on the governing parameters?
  - Growth angle
  - Contact angle
  - Pressure differential
  - Bond number (ratio of gravity to capillarity)
- Which detached growth solutions are dynamically stable?
- How does an initial crystal radius evolve to one of the following states?
  - Stable detached gap
  - Attachment to the crucible wall
  - Meniscus collapse





# Microgravity Effects

- Microgravity reduces the pressure head ( $\rho gh$ ) resulting from the weight of the melt.
  - Detached growth requires that capillary forces dominate over gravitational forces.
  - On Earth, gravity complicates a comparison of detached growth theory and experiment: the pressure head continuously decreases as the melt solidifies and the pressure varies along the height of the meniscus.
- Microgravity allows a larger value of the gap width.
  - On Earth, when the gap width becomes too large, gravity overcomes surface tension, a stable meniscus cannot be maintained, and the melt will flow down between the crystal and ampoule wall.
  - A large initial gap width will allow measurement of anisotropy in the growth angle.
- Microgravity enables a study of the dynamic stability of crystallization independent of thermal effects.



# Why Study Germanium-Silicon Alloys?



- Technological applications
  - X-ray and neutron optics (gradient crystals)
  - High-efficiency solar cell material
  - Thermoelectric converters
  - Increased carrier mobility compared to silicon, but can still be integrated into Si technology
- Characterization methods for silicon and germanium are well-established and are applicable to the alloy crystals.
- Relatively well known material properties and material parameters
- The vapor pressure of silicon and germanium melts can be neglected; they are non-toxic materials.

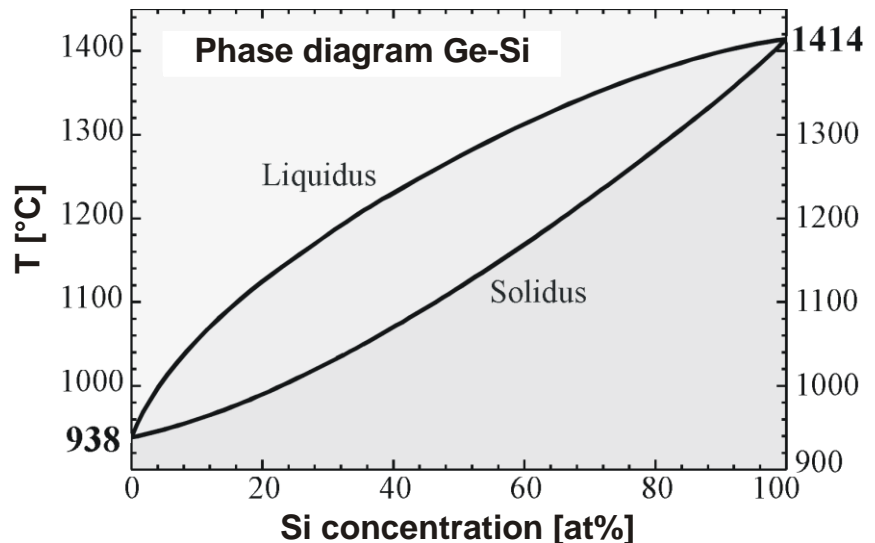




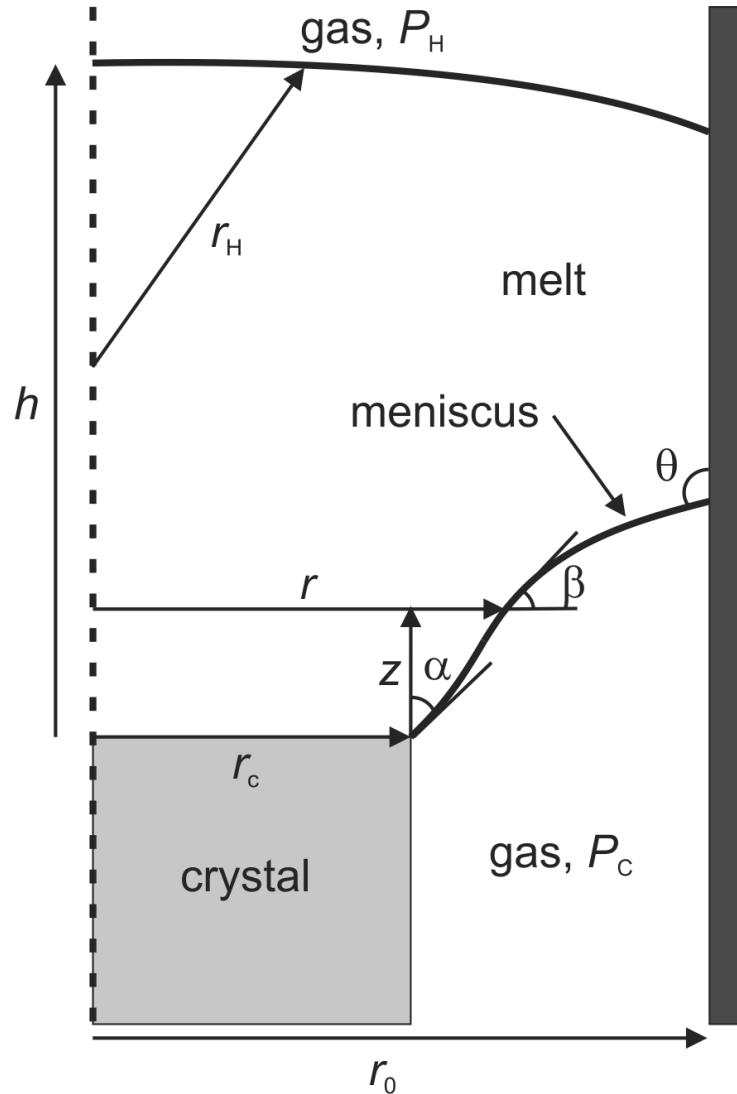
# Technological Challenges of $\text{Ge}_{1-x}\text{Si}_x$



- Large separation of solidus and liquidus curves leads to strong segregation
- Lattice mismatch (4%) leads to increased stress, cracks, high dislocation densities, polycrystalline growth
- The reactivity of liquid silicon leads to a reaction with crucible materials (sticking) as well as contamination of the melt and the crystals



# Schematic Diagram of Detached Solidification



M. P. Volz, K. Mazuruk, *Journal of Crystal Growth* 321 (2011) 29-35



# Calculation of Meniscus Shapes

$$\frac{\frac{d^2 z}{dr^2}}{\left(1 + \left(\frac{dz}{dr}\right)^2\right)^{3/2}} + \frac{\frac{dz}{dr}}{r \left(1 + \left(\frac{dz}{dr}\right)^2\right)^{1/2}} = \Delta P - Bz(r)$$

Young-Laplace Equation

$$\Delta P = \frac{\Delta P_m r_0}{\sigma}, \quad \Delta P_m = P_H - P_C + \rho g h + 2 \frac{\sigma}{r_H}$$

$\Delta P$  : Dimensionless pressure differential across the meniscus

$$B = \frac{\rho g_0 r_0^2}{\sigma} \quad \begin{array}{l} B = 3.248; \text{ Ge, } r_0 = 6 \text{ mm} \\ B = 4.651; \text{ InSb, } r_0 = 5.5 \text{ mm} \end{array}$$

$B$  : Bond number; ratio of gravity force to surface tension force

$$\frac{\partial r}{\partial s} = \cos \beta, \quad \frac{\partial z}{\partial s} = \sin \beta, \quad \frac{\partial \beta}{\partial s} = -\frac{\sin \beta}{r} + \Delta P - Bz$$

Set of 3 coupled differential equations

Boundary Conditions

$$z(0) = 0; \quad \beta(0) = 90^\circ - \alpha;$$

$$\beta(1) = \theta - 90^\circ; \quad r(1) = 1$$

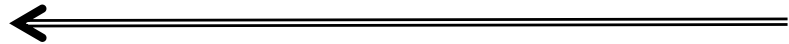
$\alpha$ : growth angle

$\theta$ : contact or wetting angle

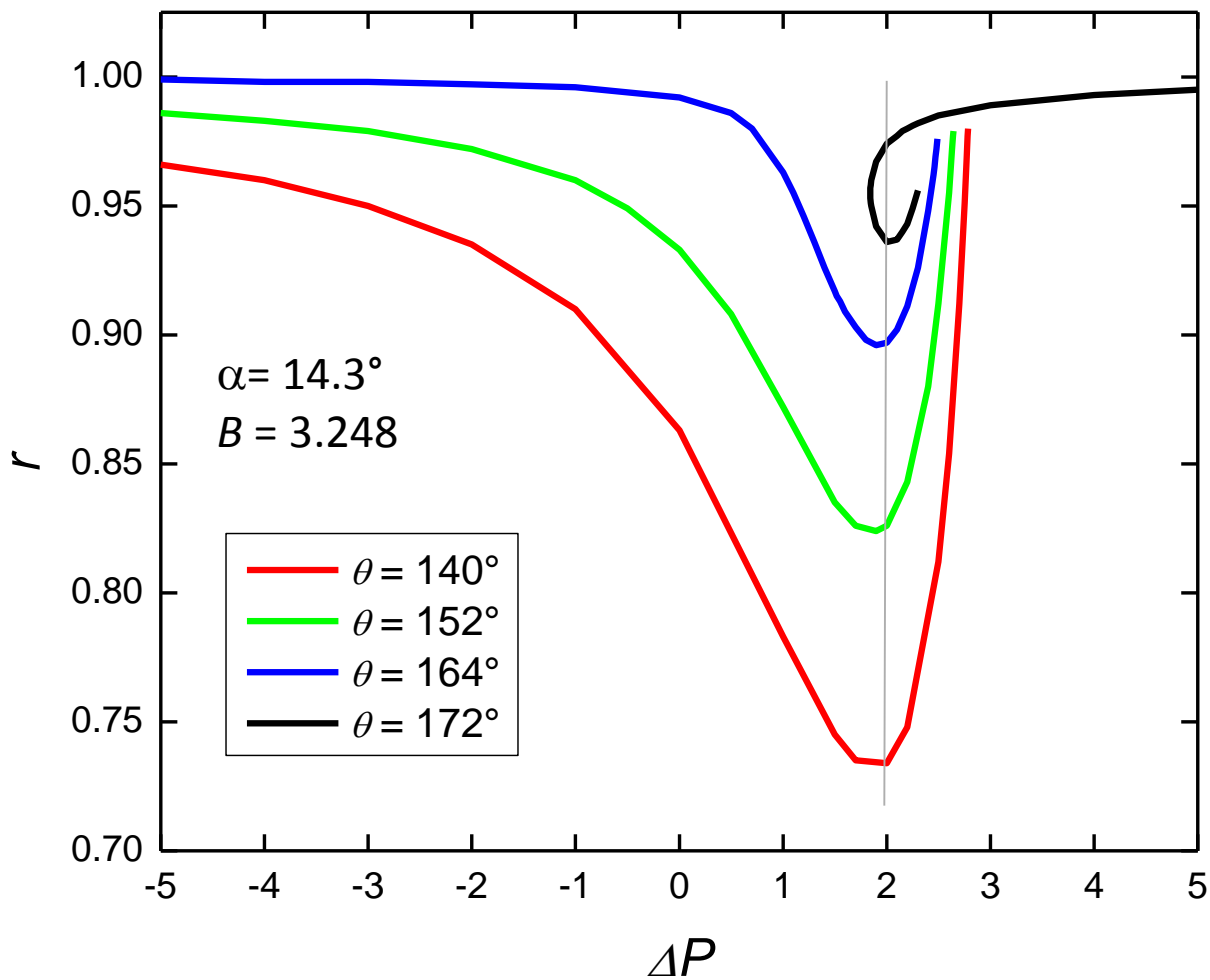


# Gap Width vs. Pressure Differential (Ge at 1g)

$\theta + \alpha < 180^\circ$



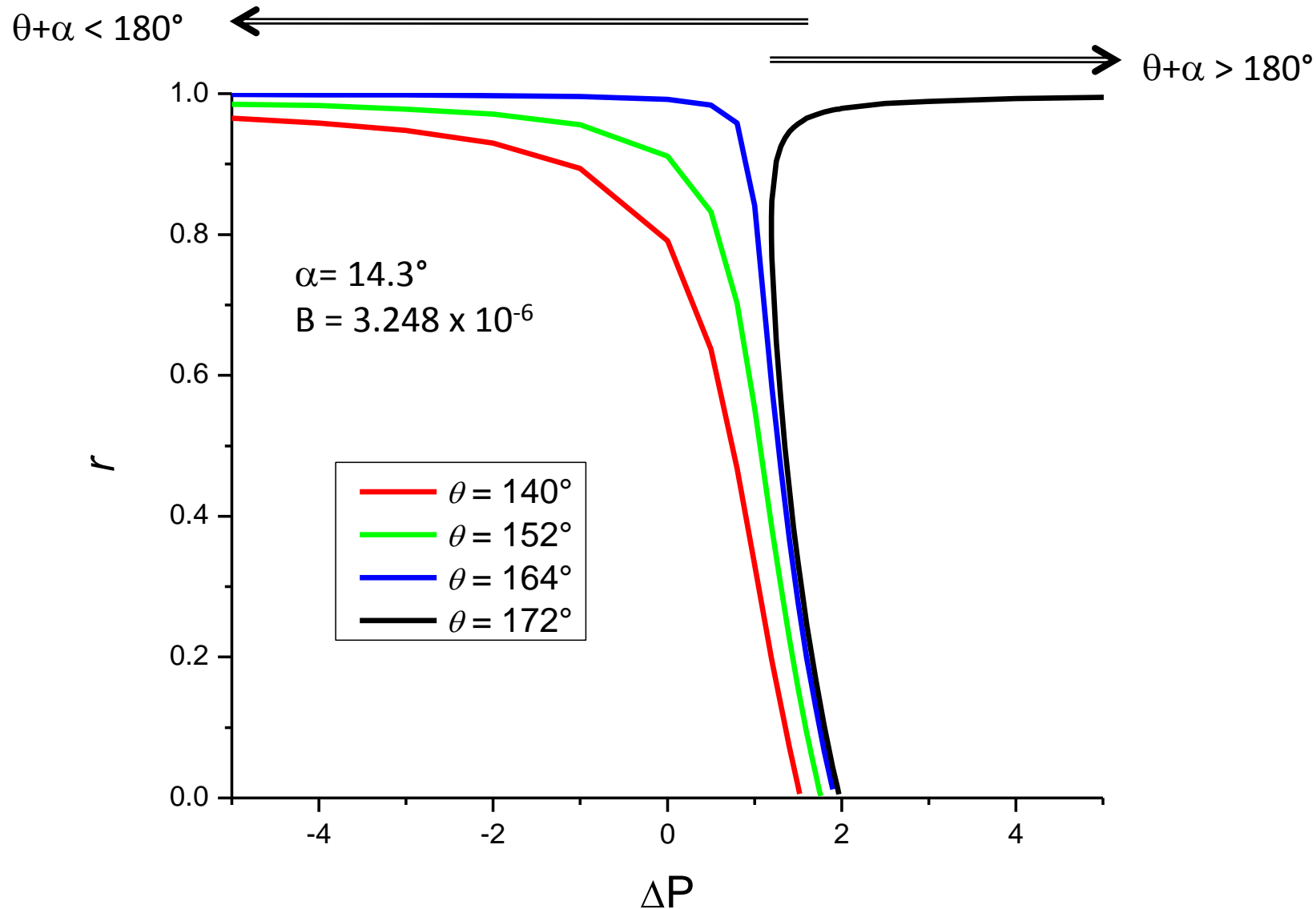
$\theta + \alpha > 180^\circ$







# Gap Width vs. Pressure Differential (Ge at $10^{-6} \times g_0$ )





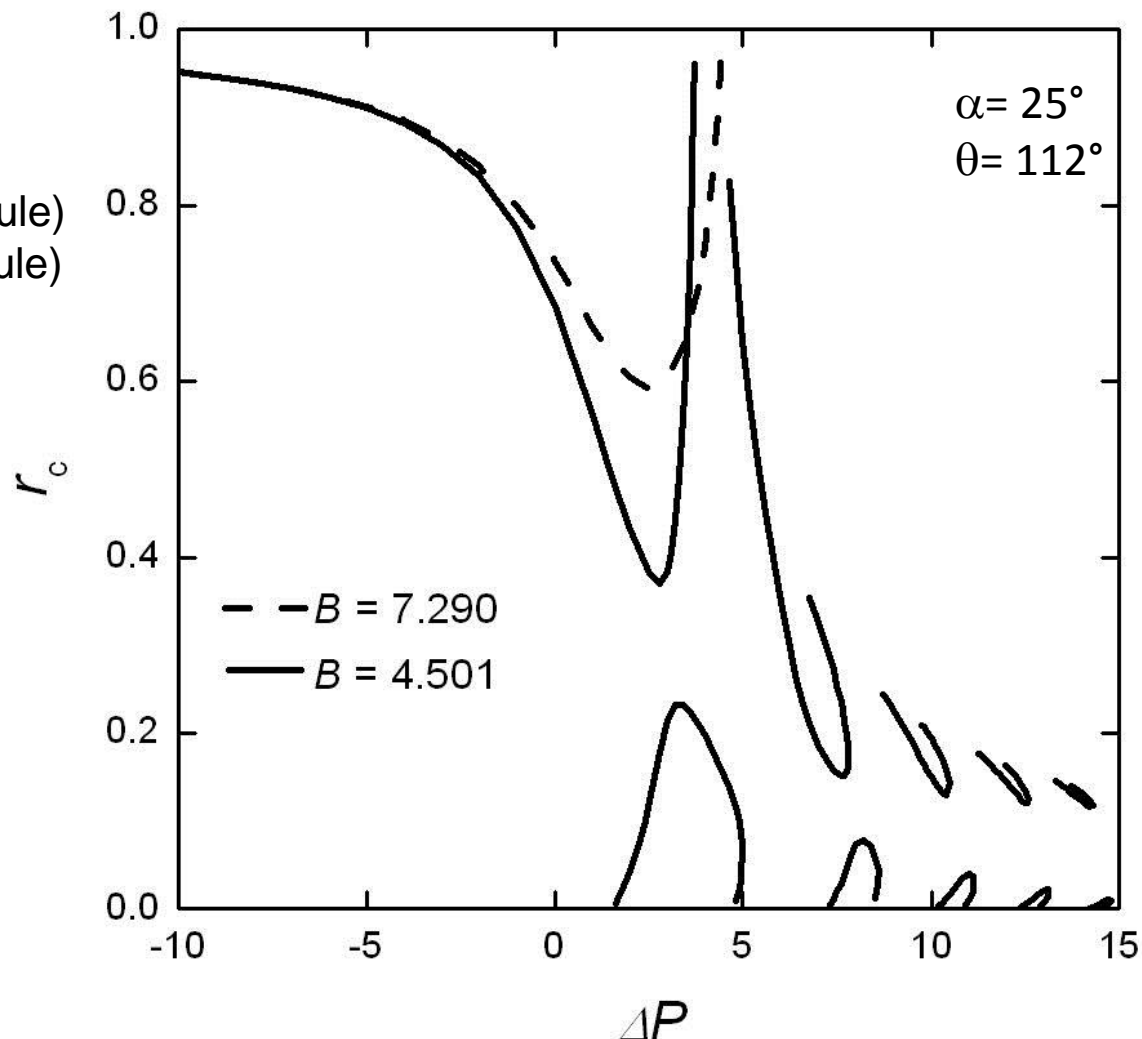
# Gap Width vs. Pressure Differential (InSb at 1g)

InSb at 1g

$B = 7.209$  (14 mm diam. ampoule)

$B = 4.501$  (11 mm diam. ampoule)

Equation nonlinearity creates  
isostates in the solution set



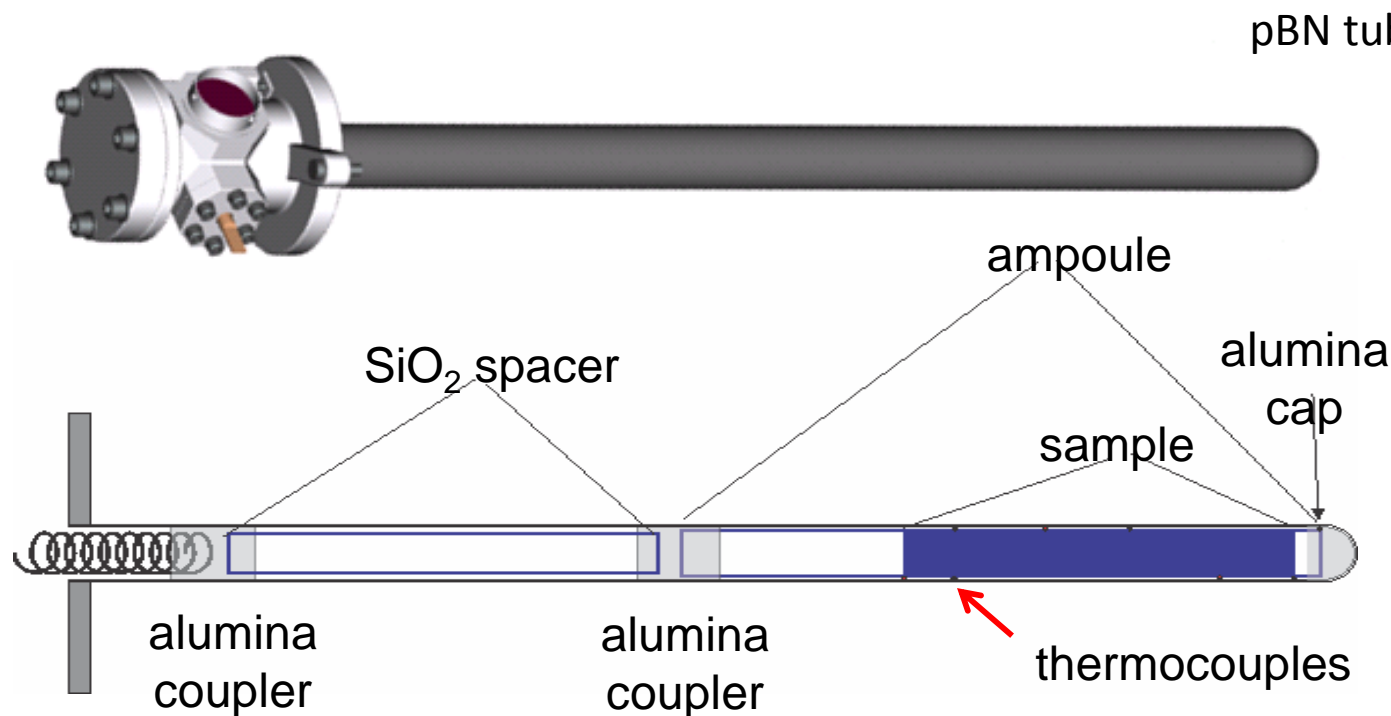


# Flight Experiments

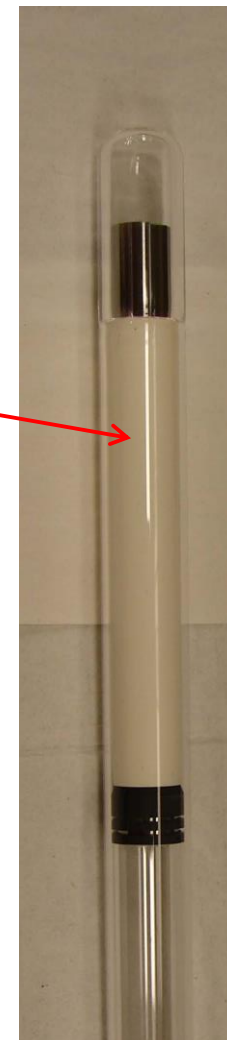
- A series of 10 GeSi and Ge:Ga samples will be processed on the ISS
- Processing parameters will be varied to assess their effect on detachment
  - Sample Material (GeSi, Ge:Ga)
    - Affects the growth angle
    - Comparison of semiconductor alloy and doped element
  - Inner Ampoule surface material ( $\text{SiO}_2$ , boron nitride)
    - Affects the contact angle
  - Pressure: positive, negative, or zero (vacuum) gas pressure below the meniscus

# Ampoule and Cartridge Layout

- A  $\text{Ge}_{1-x}\text{Si}_x$  ingot is placed inside a pyrolytic boron nitride (pBN) tube and sealed in a  $\text{SiO}_2$  ampoule.
- The ampoule is placed inside a cartridge which is inserted into the furnace.
- Thermocouples in the cartridge provide for real-time monitoring of the thermal profile



pBN tube







# Summary

- Crystals grown by the detached Bridgman method have greatly increased crystalline perfection, motivating a systematic study of the phenomenon
- A theory describing the conditions for detachment has been developed
- Only crystals where  $\alpha + \theta > 180^\circ$  are expected to achieve stable detached growth in microgravity
- Reproducible detached growth has been achieved in the laboratory under limited conditions
- Microgravity will allow the study of detachment over a range of parameters not possible to achieve on Earth
- A series of Ge and GeSi crystal growth experiments are being developed for processing on the ISS



# Contributing Personnel

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